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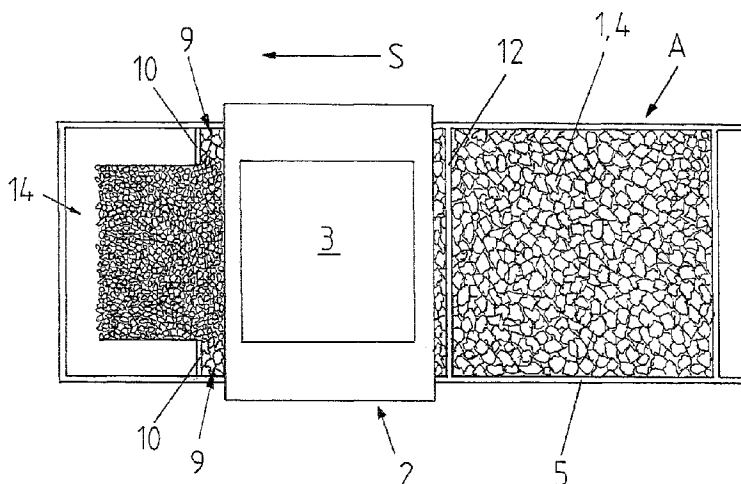
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(54) Titre : PROCEDE ET DISPOSITIF DE FRAGMENTATION ET/OU D'AFFAIBLISSEMENT D'UN MATERIAU
COULANT AU MOYEN D'UNE DECHARGE A HAUTE TENSION

(54) Title: METHOD AND DEVICES FOR FRAGMENTING AND/OR WEAKENING OF POURABLE MATERIAL BY
MEANS OF HIGH-VOLTAGE DISCHARGES



(57) **Abrégé/Abstract:**

The invention relates to a method for fragmenting and/or weakening of pourable material (1) by means of high-voltage discharges. Thereby, a material flow of the pourable material (1) is, immersed in a process liquid (4), guided past a high-voltage electrode assembly (2) with one or more high-voltage electrodes (7), while high-voltage punctures through the material (1) are produced by means of charging of the high-voltage electrodes (7) with high-voltage pulses. The zone of the material flow in which the high-voltage punctures through the material (1) are produced is delimited laterally by substantially unmoved zones (9) of the same material (1) as viewed in a guiding-past direction (S).

With the method according to the invention, it becomes possible to fragment and/or weaken pourable material (1) in a continuous process by means of high-voltage punctures in a low-wear and low-contamination manner.

ABSTRACT

The invention relates to a method for fragmenting and/or weakening of pourable material (1) by means of high-voltage discharges.

Thereby, a material flow of the pourable material (1) is, immersed in a process liquid (4), guided past a high-voltage electrode assembly (2) with one or more high-voltage electrodes (7), while high-voltage punctures through the material (1) are produced by means of charging of the high-voltage electrodes (7) with high-voltage pulses. The zone of the material flow in which the high-voltage punctures through the material (1) are produced is delimited laterally by substantially unmoved zones (9) of the same material (1) as viewed in a guiding-past direction (S).

With the method according to the invention, it becomes possible to fragment and/or weaken pourable material (1) in a continuous process by means of high-voltage punctures in a low-wear and low-contamination manner.

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**Method and devices for fragmenting and / or weakening of
pourable material by means of high-voltage discharges**

10

TECHNICAL FIELD

The invention relates to methods for the
fragmenting and / or weakening of pourable material by
means of high-voltage discharges as well as to devices
for carrying out the methods according to the preamble of
15 the independent patent claims.

STATE OF THE ART

From the state of the art, it is known to
crush the most diverse materials by means of pulsed high-
20 voltage discharges or to weaken them in such a way that
they can be crushed more easily in a subsequent
mechanical comminution process.

For the fragmenting and / or weakening of
pourable material by means of high-voltage discharges,
25 two different process types are in principle known today.

In the case of small material quantities or
strict requirements concerning the purity and / or the
target grain size of the processed material, the
fragmenting and / or weakening of the material takes
30 place in a batch operation in a closed process vessel in
which high-voltage punctures through the material are
produced.

In the case of large material quantities, the
fragmenting and / or weakening of the material is carried
35 out in a continuous process by guiding a material flow of
the to-be-crushed material past one or more high-voltage
electrodes and with these high-voltage punctures through
the material are produced.

Thereby, the problem arises, however, that in
40 a material flow which is too wide with regard to the
actual process zone in which the high-voltage punctures

5 take place, not the entire material is processed which
impairs the quality of the processed product whereas in a
too narrow material flow a part of the high-voltage
punctures take place to the lateral delimiting walls of
the device guiding the material flow, which reduces the
10 process efficiency and destroys these limiting walls over
time. This also reduces the lifetime of the system and
there is the risk that the processed material can be
contaminated with foreign material.

15 **DISCLOSURE OF THE INVENTION**

It is therefore an object to provide
continuous methods and devices for the fragmenting and /
or weakening of pourable material by means of high-
voltage discharges which do not have the aforementioned
20 disadvantages of the prior art or at least in part avoid
these.

This object is achieved by the subject-matter
of the independent claims.

According to these, a first aspect of the
25 invention relates to a method for the fragmenting and /
or weakening of pourable material, in particular of rock
fragments or crushed rock, by means of high-voltage
discharges.

Thereby, a material flow of the pourable to-
30 be-fragmented or weakened material, respectively, is,
immersed in a process liquid, guided past a high-voltage
electrode assembly with one or more high-voltage
electrodes, while by charging of the high-voltage
electrodes with high-voltage pulses, high-voltage
35 punctures are produced through the material of the
material flow. According to the invention, the zone of
the material flow in which the high-voltage punctures
through the material are produced is delimited laterally
as viewed in a guiding-past direction by substantially
40 unmoved material areas or zones, respectively, of the
same material (unmoved material zones).

5 In this way, the lateral boundaries of the
zone of the moving material flow in which the high-
voltage punctures take place (process zone) are formed by
identical but substantially unmoved material, thus making
it possible to waive devices for the lateral delimiting
10 of the actual process zone, and contamination with
foreign material is prevented.

Advantageously, thereby, the unmoved material
zones are formed from the material fed via the material
flow. For this purpose, the unmoved material zones are
15 preferably formed in such a way that the boundary zones
of the material flow are piled up at a location
downstream of the high-voltage electrode assembly such
that unmoved material zones extend laterally along the
entire length of the process zone.

20 Furthermore, it is preferred that the moving
material flow and the unmoved material zones are formed
in this way that the pourable material is provided in a
trough-like or tank-like device, respectively, flooded
with process liquid, the bottom of which is formed by a
25 conveyor belt or a conveyor chain in a central zone and
is fixed in the boundary zones. In this way, the unmoved
material zones can be created in a controlled and low-
wear manner.

Any material which is carried away by the
30 material flow from the unmoved material zones is
preferably replaced by material from the material flow
and / or replaced by separately supplied material.
Depending on the structure of the device used for the
carrying out of the method, the one or the other variant
35 may be particularly advantageous or also a combination
thereof.

A second aspect of the invention relates to a
further method for the fragmenting and / or weakening of
pourable material, in particular of rock fragments or
40 crushed rock, by means of high-voltage discharges.

5 Thereby, a material flow from the pourable
to-be-fragmented or weakened material, respectively, is,
immersed in a process liquid, guided past a high-voltage
electrode assembly with one or more high-voltage
electrodes, while high-voltage punctures are produced
10 through the material of the material flow by charging of
the high-voltage electrodes with high-voltage pulses.
According to the invention, the central zone of the
material flow is charged with high-voltage punctures
while the boundary zones of the material flow remain
15 substantially unaffected by high-voltage punctures.
Subsequently, the material of the central zone of the
material flow treated with high-voltage punctures is
separated from the untreated material of the boundary
zones of the material flow downstream of the high-voltage
20 electrode assembly. In this method, the zone of the
material flow in which the high-voltage punctures take
place (process zone) is laterally limited by material of
the material flow which is not treated with high-voltage
punctures, from which also here the advantage arises
25 that, on the equipment side, devices for the lateral
delimiting of the actual process zone can be forgone and
a contamination with foreign material is prevented.

 In this case, it is preferred that the
untreated material from the boundary zones of the
30 material flow which is separated from the treated
material from the central zone of the material flow is
fed entirely or partially again into the material flow at
a location upstream from the high-voltage electrode
assembly, advantageously into the central zone of the
35 material flow. In this way, the proportion of untreated
material, i.e. material which is not treated with high-
voltage punctures, can be minimized.

 In a preferred embodiment of the method
according to the second aspect of the invention, an
40 annular-shaped material flow is guided past the high-
voltage electrode assembly. Thereby, the material of the

5 boundary zones remains in the material flow downstream of
the high-voltage electrode assembly and is passes the
high-voltage electrode assembly again during each cycle
of the material flow, while the material in the central
zone of the material flow is partly or completely removed
10 from the material flow downstream of the high-voltage
electrode assembly and is replaced by new material which
is then guided past the high-voltage electrode assembly
and charged with high-voltage punctures.

In another preferred embodiment of the method
15 according to the second aspect of the invention, an
annular-shaped material flow is guided past the high-
voltage electrode assembly. Thereby, the material in the
central zone of the material flow is removed partly or
completely from the material flow downstream of the high-
20 voltage electrode assembly, the material of the boundary
zones is subsequently guided into the thereby created gap
in the center of the material flow, and then new material
is introduced into the material flow in the boundary
zones before it is again guided past the high-voltage
25 electrode assembly and charged with high-voltage
punctures.

The formation of an annular-shaped material
flow has the advantage that the material remaining in the
material flow is automatically guided past the high-
30 voltage electrode assembly again, and then, depending on
the embodiment of the method, acts as a delimiter of the
process zone again or is charged with high-voltage
punctures and is fragmented and / or weakened.

In the case of the two previously described
35 preferred embodiments of the method according to the
second aspect of the invention, the annular-shaped
material flow is preferably formed by providing the
material on a carrousel-like device and by rotating this
device about a central, substantially vertical axis is
40 guided past the high-voltage electrode assembly. In this
way, the annular-shaped material flow can be produced

5 with a relatively low complexity in terms of system technology.

In the methods according to the first and second aspects of the invention, the high-voltage electrode assembly advantageously comprises a matrix of
10 several high-voltage electrodes, which are each charged with high-voltage pulses in the intended operation. As a result, a two-dimensional charging of the guided past material flow with high-voltage punctures can be achieved.

15 Preferably, thereby, each of the high-voltage electrodes of the matrix has its own high-voltage generator with which it is charged with high-voltage pulses independently of the other high-voltage electrodes. This makes it possible to ensure a uniform
20 and high energy input into the material flow over the entire surface of the matrix, or also to specifically charge individual zones with different amounts of energy.

As a counter-electrode for the high-voltage electrodes of the high-voltage electrode assembly, in
25 accordance with a preferred embodiment of the methods according to the first and the second aspect of the invention, an element delimiting the bottom side of the material flow in the region of the high-voltage-electrode assembly is used, such that high-voltage punctures occur
30 between the respective high-voltage electrode and this element through the material flow by the charging of the high-voltage electrodes with high-voltage pulses. This element is preferably formed by a conveyor belt or a conveyor chain with which the material flow is guided
35 past the high-voltage electrode assembly. In this case, the high-voltage electrodes of the high-voltage electrode assembly are preferably immersed in the material flow. With this variant of the method, the material of the material flow can be impacted particularly intensively,
40 because the high-voltage punctures occur over the entire thickness of the material flow.

5 In another preferred embodiment of the
methods according to the first and the second aspect of
the invention, each of the high-voltage electrodes of the
high-voltage electrode assembly has one or more of its
own counter-electrodes, i.e. exclusively assigned to the
10 respective high-voltage electrode, which is or are
arranged laterally besides and / or below this high-
voltage electrode, such that high-voltage punctures
between the high-voltage electrode and the counter-
electrode or counter-electrodes, respectively, through
15 the material flow guided past these are produced by the
charging of the specific high-voltage electrode with
high-voltage pulses. In this case, the high-voltage
electrodes and / or the counter-electrodes are preferably
immersed in the material flow.

20 This results in the advantage that the
breakdown voltage is substantially decoupled from the
thickness of the material flow, such that also material
flows from large pieces of material can readily be
processed. A further advantage of this embodiment is that
25 it offers the greatest possible freedom of design with
respect to the supporting surface or the conveying
device, respectively, for the material flow in the region
of the process zone because the bottom surface of the
process zone is not required as counter-electrode.

30 In the last-mentioned preferred embodiment,
it is further preferred that the counter-electrodes are
supported by the respective high-voltage electrode or by
its support structure, respectively.

35 As stated above, it is possible with the
inventive methods to fragment and / or weaken pourable
material in a continuous process by means of high-voltage
discharges in a low-wear and low-contamination manner.

40 A third and a fourth aspect of the invention
relate to a device for carrying out the method according
to the first aspect or the second aspect of the
invention, respectively.

5 The device comprises a high-voltage electrode
assembly with one or more high-voltage electrodes, as
well as one or several high-voltage generators, by means
of which the high-voltage electrode or the high-voltage
electrodes of the high-voltage electrode assembly is or
10 are chargeable with high-voltage pulses.

 Furthermore, the device comprises an
advantageously linearly conveying conveying device, e.g.
in the form of a conveyor belt or a conveyor chain, which
is arranged in a basin which is filled or fillable with a
15 process liquid, and with which, in the intended
operation, a material flow of a pourable, to-be-
fragmented and / or weakened material, can be, immersed
in the process liquid, guided past the high-voltage
electrode assembly, while high-voltage punctures through
20 the material flow are produced as a result of a charging
of the high-voltage electrode assembly with high-voltage
pulses.

 In this case, the device according to the
third aspect of the invention is designed in such a way
25 that, in the intended operation during the guiding past
of the material flow, in the boundary zones of the region
in which the high-voltage punctures through the material
of the material flow are produced, the material of the
material flow piles up to a substantially unmoved
30 material zone each, which is essentially unaffected by
the high-voltage punctures. With an advantage, the device
comprises devices for the selective piling up of the
material flow, e.g. baffles or lateral delimiting walls
for the material flow with recesses in which the material
35 piles up. Due to the fact that the lateral delimiters of
the zone of the moving material flow in which the high-
voltage punctures take place (process zone) are formed by
identical but substantially unmoved material, wear-
intensive devices for the lateral delimiting of the
40 actual process zone can be forgone, which has a positive
effect on the operating costs and on the maintenance-

5 related standstill times of the device, and also makes possible a process control with low foreign material contamination.

In contrast to the device according to the third aspect of the invention, the device according to the fourth aspect of the invention is structured in such a way that, in the intended operation during the guiding of the material flow past the high-voltage electrode assembly, the central zone of the material flow is charged with high-voltage punctures while the boundary zones of the material flow are essentially unaffected by the high-voltage punctures. In addition, the device comprises a separation device, by means of which in the intended operation the material of the boundary zones of the material flow is separated from the material of the central zone of the material flow downstream of the high-voltage electrode assembly. Advantageously, the device further comprises additional devices for returning the material of the boundary zones of the material flow, which is separated by the separation device, back into the material flow upstream of the high-voltage electrode assembly, such that this material can be again guided past the high-voltage electrode assembly, for the fragmenting and / or weakening of the same or for the renewed formation of the boundary zones of the material flow.

Due to the fact that the lateral delimiters of the zone of the moving material flow, in which the high-voltage punctures take place (process zone), are formed by the material of the moving material flow, wear-intensive devices for the lateral delimiting of the actual process zone can also be forgone here, which as has already been mentioned positively affects the operating costs and the maintenance-related standstill times of the device and also makes possible a process control with low foreign material contamination.

5 A fifth aspect of the invention relates to a further device for carrying out of the method according to the second aspect of the invention.

 This device also comprises a high-voltage electrode assembly with one or more high-voltage
10 electrodes as well as one or more high-voltage generators, by means of which the high-voltage electrode or the high-voltage electrodes of the high-voltage electrode assembly is or are chargeable with high-voltage pulses.

15 Furthermore, the device comprises a conveying device in the form of a carousel-like device, with which in the intended operation a material flow of a pourable to-be-fragmented and / or weakened material, immersed in a process liquid, can be guided past the high-voltage
20 electrode assembly, while high-voltage punctures through the material flow are produced by charging of the high-voltage electrode assembly with high-voltage pulses.

 Furthermore, the device comprises a material removal device, by means of which, in the intended
25 operation, material is removed from the central zone of the material flow downstream of the high-voltage electrode assembly, and a material feeding device, by means of which, in the intended operation, in a region downstream of the material removal device and upstream of
30 the high-voltage electrode assembly, pourable to-be-fragmented and / or weakened material can be fed into the material flow.

 Also in this device, because the lateral delimiters of the zone of the moving material flow, in
35 which the high-voltage punctures take place (process zone), are formed by the material of the material flow, wear-intensive devices for the lateral delimiting of the actual process zone can be forgone, with the already mentioned positive effects on the operating costs, the
40 maintenance-related standstill times of the device, and

5 the foreign material contamination of the processed material.

In addition, this device has the advantage that material remaining in the material flow is automatically guided past the high-voltage electrode assembly again, and then, depending on the embodiment of the device, again serves as a delimiter of the process zone or is charged with high-voltage punctures and fragmented or weakened, respectively.

15 **BRIEF DESCRIPTION OF THE DRAWINGS**

Further embodiments, advantages, and applications of the invention result from the dependent claims and from the following description with reference to the figures. Thereby show:

20 Fig. 1 a longitudinal section along the line B-B in Fig. 3 through a first device according to the invention;

Fig. 2 a top view from above of the device from Fig. 1;

25 Fig. 3 a cross-section through the device along the line A-A in Fig. 1;

Fig. 4 a longitudinal section along the line D-D in Fig. 6 through a second device according to the invention;

30 Fig. 5 a top view from above of the device of Fig. 4;

Fig. 6 a cross-sectional view of the device along the line C-C in Fig. 4; and

35 Fig. 7 a side view of one of the high-voltage electrodes of the devices;

Fig. 8 a side view of a first variant of the high-voltage electrode from Fig. 7; and

Fig. 9 a side view of a second variant of the high-voltage electrode from Fig. 7.

5

MODES FOR CARRYING OUT THE INVENTION

The figures 1 to 3 show a first device according to the invention for the fragmenting of pourable material 1 by means of high-voltage discharges, once in a longitudinal section along the line B-B in Fig. 3 (Fig. 1), once in a top view from above (Fig. 2) and once in a cross-section along the line A-A in Fig. 1 (Fig. 3).

As can be seen, the device comprises a high-voltage electrode assembly 2 with a matrix of 16 high-voltage electrodes 7, which as viewed in the material flow direction S are arranged in four successively arranged rows, each with four high-voltage electrodes 7 (only one of the high-voltage electrodes is provided with the reference numeral 7 in the figures for the sake of clarity).

In the illustrated intended operation, the high-voltage electrodes 7 are each charged with high-voltage pulses by a high-voltage generator 3 arranged directly above them.

A conveyor belt 6 is arranged below the high-voltage electrode assembly 2, arranged in a basin 5 flooded with water 4 (process liquid), with which a material flow of a pourable, to-be-fragmented material 1, in the present case fragments of noble metal ore, is guided from the feeding side A of the device in the material flow direction S past the high-voltage electrodes 7 of the high-voltage electrode assembly 2, while high-voltage punctures through the material 1 are produced by the charging of the high-voltage electrode assembly 2 with high-voltage pulses. Thereby, the material 1 of the material flow is immersed in the water 4 located in the basin 5, as well as the high-voltage electrodes 7 arranged above.

The height of the material flow is adjusted before the inlet into the region between the conveyor

5 belt 6 and the high-voltage electrode assembly 2 (process zone) by a passage-limiting plate 12.

As can be seen from Fig. 3, as viewed in the flow direction S, the conveyor belt 6 does not extend over the entire width of the basin 5, but in the region of the basin center over the width of the process zone in which the high-voltage punctures through the material flow occur. Along the edge regions of the basin 5, supporting sections 13 which are fixedly connected to the side wall of the basin 5 extend at the level of the upper side of the conveyor belt 6, at which ends baffle plates 10 are arranged downstream of the high-voltage electrode assembly 2 which lead to a piling up of the material 1 in the edge regions of the basin 5 on the supporting sections 13 and thereby forms substantially unmoved material zones 9 along these edge regions, which laterally delimit the process zone in which the high-voltage punctures through the material 1 of the material flow are produced.

As can be seen in particular from figures 1 and 3, the material 1 transported on the conveyor belt 6 is increasingly fragmented during the passage through the process zone, while the unmoved material 1 in the edge regions 9 of the basin 5 remains substantially unchanged.

Downstream of the high-voltage electrode assembly 2, the fragmented material 1 emerging from the process zone is discharged from the conveyor belt 6 into a collecting funnel 14 at the end of the basin 5, from where it is conveyed by a conveying device (not shown) out of the basin 5.

35 The figures 4 to 6 show a second device according to the invention for fragmenting pourable material 1 by means of high-voltage discharges, once in a longitudinal section along the line D-D in Fig. 6 (Fig. 4), once in a top view from above (Fig. 5) and once in a cross-section along the line C-C in Fig. 4 (Fig. 6).

5 This device differs from the device shown in figures 1 to 3 in that here the conveyor belt 6 as viewed in a flow direction S extends over the entire width of the basin 5 such that the moving material flow covers the entire width of the basin 5.

10 As can be seen in particular from figures 4 and 6, the central zone of the material flow is charged with high-voltage punctures during the passage of the process zone, which leads to an increasing fragmenting of the material 1 in this zone, while the boundary zones of
15 the material flow remain virtually unaffected by high-voltage punctures, such that the material 1 guided therein retains its original fragmentation size.

 Downstream of the high-voltage electrode assembly 2, the material flow emerging from the process
20 zone is discharged from the conveyor belt 6 into three collecting funnels 14, 14a, 14b at the end of the basin 5, which are separated from each other by separation walls 11 and extend side by side over the entire width of the conveyor belt 6. Thereby, the separation walls 11 are
25 arranged in such a way that the fragmented material 1 from the central zone of the material flow is discharged into the center collecting funnel 14 while the non-fragmented material 1 from the boundary zones of the material flow is discharged into the outer collection
30 funnels 14a, 14b.

 The fragmented material 1, which is discharged into the center collecting funnel 14, is conveyed out of the basin 5 by means of a conveying device (not shown) and fed to another use. The non-
35 fragmented material 1, which is discharged into the outer collection funnels 14a, 14b, is conveyed out of the basin 5 by means of conveying devices (not shown) and fed into the material flow again on the feeding side A of the device.

40 As can be seen from Fig. 7 which shows one of the high-voltage electrodes 7 of the high-voltage

5 electrode assemblies 2 of the devices in the side view,
each of the high-voltage electrodes 7 comprises a
corresponding counter-electrode 8 lying on ground
potential, which is laterally arranged besides the
respective high-voltage electrode 7 in such a way that in
10 the illustrated operation, by the charging of the
specific high-voltage electrode 7 with high-voltage
pulses, high-voltage punctures between the high-voltage
electrode 7 and the corresponding counter-electrode 8 are
produced through the material 1 of the material flow.
15 Thereby, the counter-electrode 8 is attached to the
supporting structure of the high-voltage electrode 7.

The figures 8 and 9 show side views of two
variants of the high-voltage electrode from Fig. 7.

Fig. 8 shows a high-voltage electrode 7 which
20 differs from the one shown in Fig. 7 essentially in that
it comprises two identical counter-electrodes 8 which are
mirror-inverted facing. A further difference is that this
high-voltage electrode 7 has a straight electrode tip.

Fig. 9 shows a high-voltage electrode 7 which
25 differs from the one shown in Fig. 8 essentially therein
that here shown in Fig. 8 the two mirror-inverted facing
counter electrodes 8 are connected to a single, U-shaped
counter-electrode 8 below the high-voltage electrode 7.

In the intended operation, the high-voltage
30 electrodes 7 and the counter-electrodes 8 are preferably
immersed in the material flow.

While there are described preferred
embodiments of the invention in the present application,
it is to be clearly pointed out that the invention is not
35 limited thereto and can also be carried out in another
manner within the scope of the following claims.

The embodiments of the invention in which an exclusive property or privilege is claimed are defined as follows:

1. Method for fragmenting and/or weakening of pourable material by means of high-voltage discharges, comprising the steps of:

a) providing a high-voltage electrode assembly, which is assigned to a high-voltage generator by means of which it is chargeable with high-voltage pulses;

b) guiding of a material flow of pourable material, immersed in a process liquid, past the high-voltage electrode assembly; and

c) producing of high-voltage punctures through the material flow during the guiding thereof past the high-voltage electrode assembly by means of charging of the high-voltage electrode assembly with high-voltage pulses,

wherein the zone of the material flow in which high-voltage punctures through the material of the material flow are produced as viewed in a guiding-past direction is laterally delimited by substantially unmoved zones of the same material.

2. Method according to claim 1, wherein the substantially unmoved zones are produced in that the boundary zones of the material flow are piled up downstream of the high-voltage electrode assembly.

3. Method according to claim 1 or 2, wherein the material flow and the substantially unmoved zones are produced in that

the material is provided in a trough-like or tank-like device, the bottom of which is formed in a central zone by a conveyor belt or a conveyor chain and is fixed in the boundary zones.

4. Method according to any one of claims 1 to 3, wherein material which is carried away from the material flow from the substantially unmoved zones, is replaced by material from the material flow.

5. Method according to any one of claims 1 to 3, wherein material which is carried away from the material flow from the substantially unmoved zones, is replaced by separately supplied material.

6. Method for fragmenting and/or weakening of pourable material by means of high-voltage discharges, comprising the steps of:

- a) providing a high-voltage electrode assembly which is assigned to a high-voltage generator by means of which it is chargeable with high-voltage pulses;

- b) guiding of a material flow of pourable material, immersed in a process liquid, past the high-voltage electrode assembly; and

- c) producing of high-voltage punctures through the material flow during the guiding thereof past the high-voltage electrode assembly by means of charging of the high-voltage electrode assembly with high-voltage pulses,

wherein the high-voltage punctures are produced in such a way that the central zone of the material flow is charged with high-voltage punctures while the boundary zones of the

material flow remain unaffected by high-voltage punctures, and wherein the material of the central zone of the material flow is separated from the material of the boundary zones downstream of the high-voltage electrode assembly after the charging with high-voltage punctures.

7. Method according to claim 6, wherein the material from the boundary zones which is separated from the material from the central zones is fed back into the material flow completely or partially upstream of the high-voltage electrode assembly.

8. Method according to claim 7, wherein the material from the boundary zones which is separated from the material from the central zones is fed back into the central zone of the material flow.

9. Method according to any one of claims 6 to 8, wherein an annular-shaped material flow is guided past the high-voltage electrode assembly, wherein the material of the boundary zones remains in the material flow downstream of the high-voltage electrode assembly, and again passes the high-voltage electrode assembly at each cycle of the material flow, while the material in the central zone of the material flow is removed from the material flow downstream of the high-voltage electrode assembly and is at least partially replaced by new material, before the material flow is again guided past the high-voltage electrode assembly and charged with high-voltage punctures.

10. Method according to any one of claims 6 to 8, wherein an annular-shaped material flow is guided past the high-voltage electrode assembly, wherein the material in the central zone of the material flow is removed from the material flow downstream of the high-voltage electrode assembly, the material of the outer and/or the inner boundary zone is then at least partially guided into the center of the material flow and then new material is introduced into the outer and/or inner boundary zone of the material flow, before it is again guided past the high-voltage electrode assembly and charged with high-voltage punctures.

11. Method according to claim 9 or 10, wherein the material flow is formed in that the material is provided on a carousel device, and by rotation of this device around a central, substantially vertical axis is guided past the high-voltage electrode assembly.

12. Method according to any one of claims 1 to 11, wherein the high-voltage electrode assembly comprises a matrix of several high-voltage electrodes, each of which are charged with high-voltage pulses.

13. Method according to claim 12, wherein a specific high-voltage generator is assigned to each high-voltage electrode, with which it is charged with high-voltage pulses independently of the other high-voltage electrodes.

14. Method according to any one of claims 1 to 13, wherein as a counter-electrode for the high-voltage electrodes of the

high-voltage electrode assembly an element delimiting the bottom side of the material flow in the region of the high-voltage electrode assembly is used.

15. Method according to claim 14, wherein the element delimiting the bottom side of the material flow in the region of the high-voltage electrode assembly is a conveyor belt or a conveyor chain, with which the material flow is guided past the high-voltage electrode assembly.

16. Method according to one of the claims 1 to 13, wherein each of the high-voltage electrodes of the high-voltage electrode assembly has at least one specific counter-electrode which is arranged laterally beside and/or below it in such a way that by means of charging of the respective high-voltage electrode with high-voltage pulses, high-voltage punctures between the high-voltage electrode and the counter-electrode through the material flow guided past these are produced.

17. Device for carrying out the method according to claim 1, comprising:

a) a high-voltage electrode assembly, which is assigned to a high-voltage generator, with which it is chargeable with high-voltage pulses; and

b) a conveying device, arranged in a basin which is filled or fillable with a process liquid, with which in the intended operation a material flow of a pourable, to be fragmented and/or weakened material, immersed in a process liquid, is guided past the high-voltage electrode assembly while high-voltage punctures through the material flow are

produced by means of charging of the high-voltage electrode assembly with high-voltage pulses,

wherein the device is structured such that, in the intended operation, during the guiding past of the material flow, in the lateral zones of the zone in which the high-voltage punctures through the material of the material flow are produced, the material of the material flow each is piled up to a substantially unmoved material zone, which is essentially unaffected by the high-voltage punctures.

18. Device according to claim 17, wherein the conveying device is in the form of a conveyor belt or conveyor chain.

19. Device according to claim 17 or 18, wherein the device comprises damming devices, or lateral delimiting walls for the material flow with recesses therein, for piling up of the material flow to the substantially unmoved material zones.

20. Device according to claim 20, wherein the damming devices are baffles.

21. Device for carrying out the method according to claim 6, comprising:

c) a high-voltage electrode assembly, which is assigned to a high-voltage generator, with which it is chargeable with high-voltage pulses; and

d) a conveying device, arranged in a basin which is filled or fillable with a process liquid, with which in the intended operation a material flow of a pourable, to be fragmented and/or to be weakened material, immersed in a

process liquid, is guided past the high-voltage electrode assembly while high-voltage punctures through the material flow are produced by means of charging of the high-voltage electrode assembly with high-voltage pulses,

wherein the device is structured such that, in the intended operation, during the guiding past of the material flow, the central zone of the material flow is charged with high-voltage punctures, while the boundary zones of the material flow remain substantially unaffected by the high-voltage punctures, and wherein the device comprises a separation device, by means of which in an intended operation the material of the boundary zones of the material flow is separated from the material of the central zone of the material flow downstream of the high-voltage electrode assembly.

22. Device according to claim 21, wherein the conveying device is in the form of a conveyor belt or conveyor chain.

23. Device according to claim 21 or 22, further comprising a re-feeding device for refeeding the by means of the separation device separated material of the boundary zones of the material flow back into the material flow upstream of the high-voltage electrode assembly.

24. Device for carrying out the method according to claim 11, comprising:

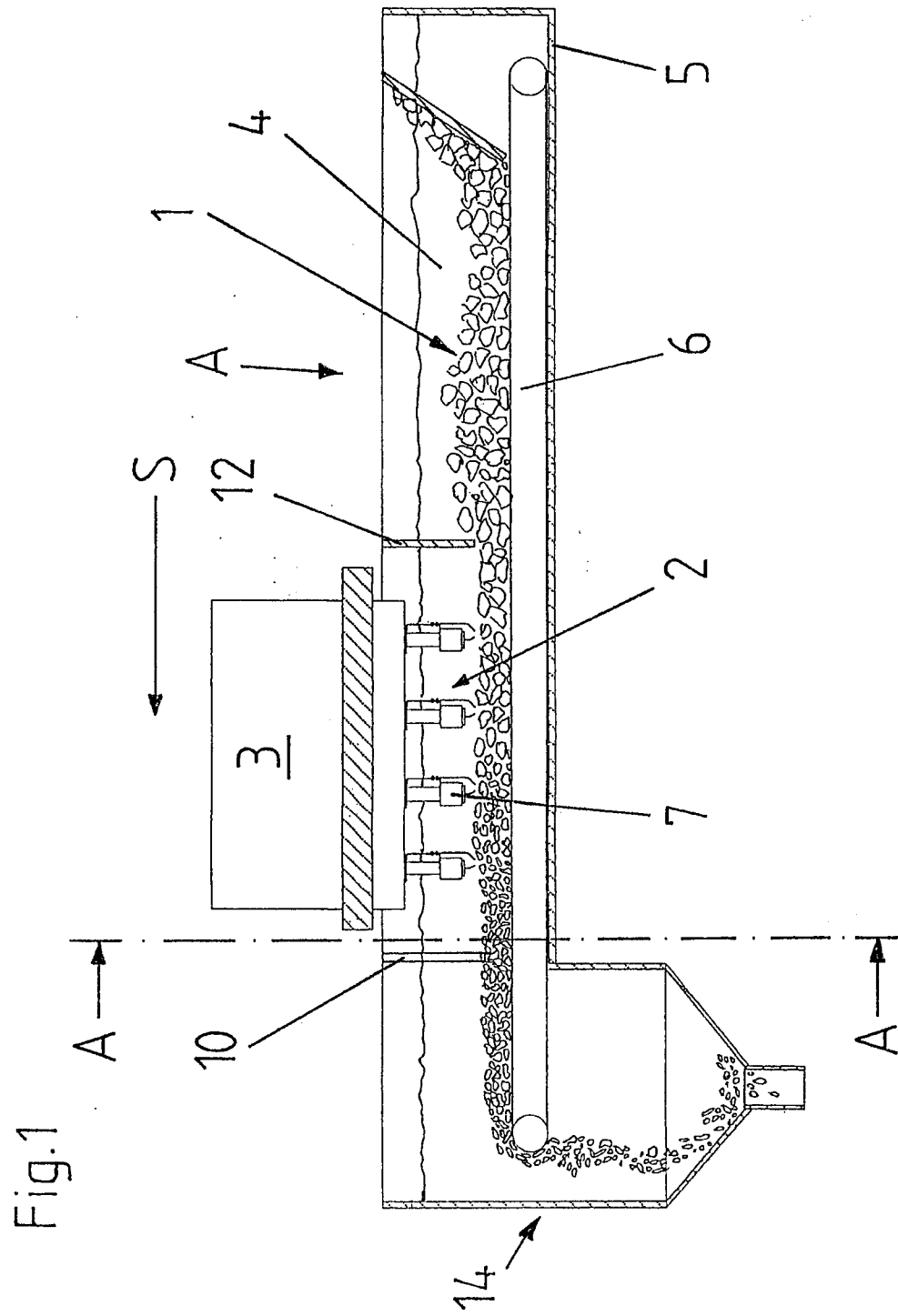
a) a high-voltage electrode assembly, which is assigned to a high-voltage generator, with which it is chargeable with high-voltage pulses;

b) a conveying device in the form of a carousel device, with which in the intended operation a material flow of a pourable, to be fragmented and/or to be weakened material, immersed in a process liquid, is guided past the high-voltage electrode assembly while high-voltage punctures through the material flow are produced by means of charging of the high-voltage electrode assembly with high-voltage pulses;

c) a material removal device with which, in the intended operation, material is removed from the material flow from the central zone of the material flow downstream of the high-voltage electrode assembly; and

d) a material feeding device with which, in the intended operation, pourable, to be fragmented and/or to be weakened material is fed into the material flow in a region downstream of the material removal device and upstream of the high-voltage electrode assembly.

25. Device according to claim 24, wherein one or more guiding devices are present, by means of which, in the intended operation, the material of the outer and/or the inner boundary zone of the material flow downstream of the material removal device is guided at least partially into the center of the material flow, and wherein the material feeding device is structured such that with it, in the intended operation, downstream of the guiding devices, to be fragmented and/or weakened material is fed into the outer and/or inner boundary zone of the material flow, before it is again guided past the high-voltage electrode assembly and charged with high-voltage punctures.



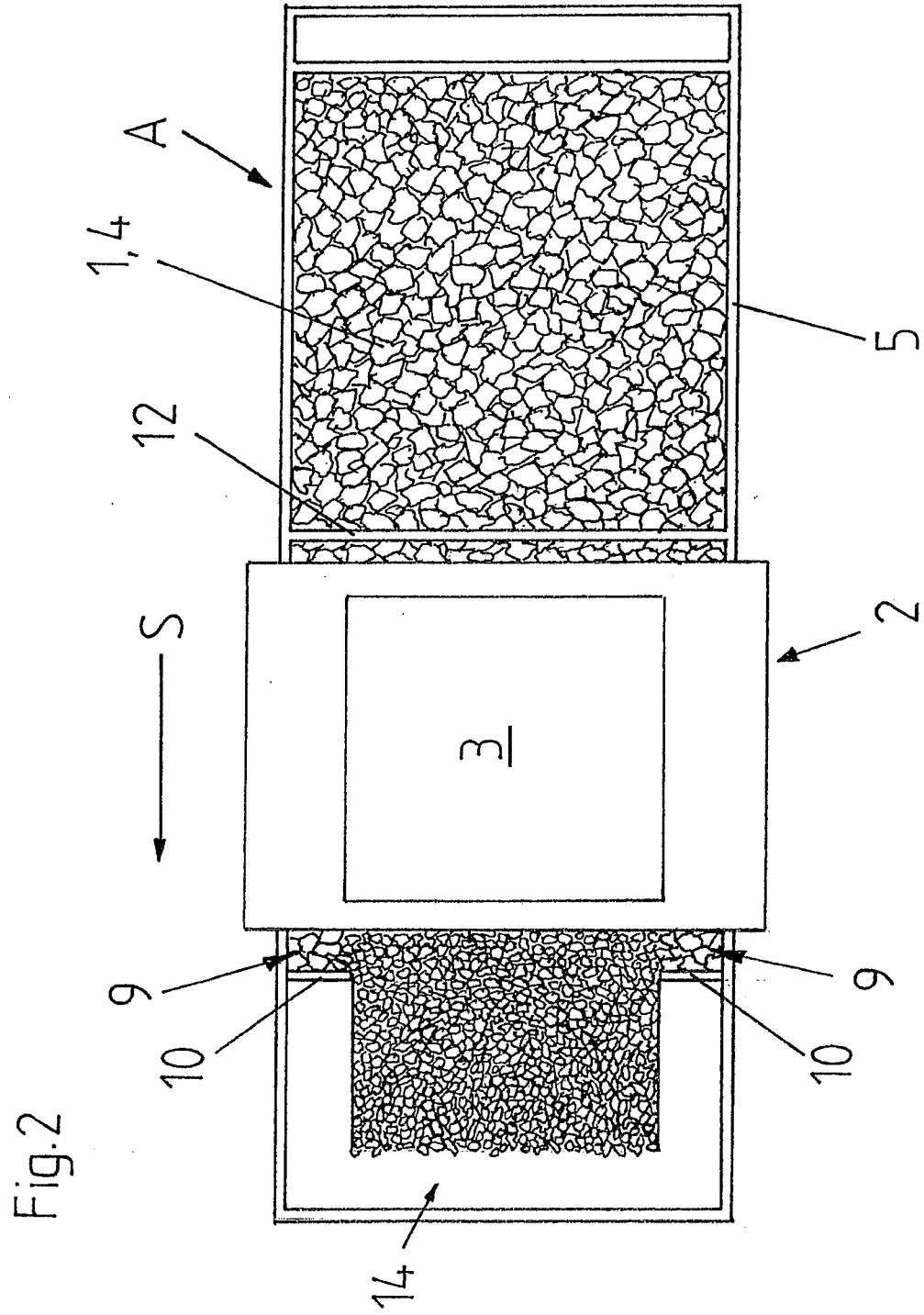


Fig. 3

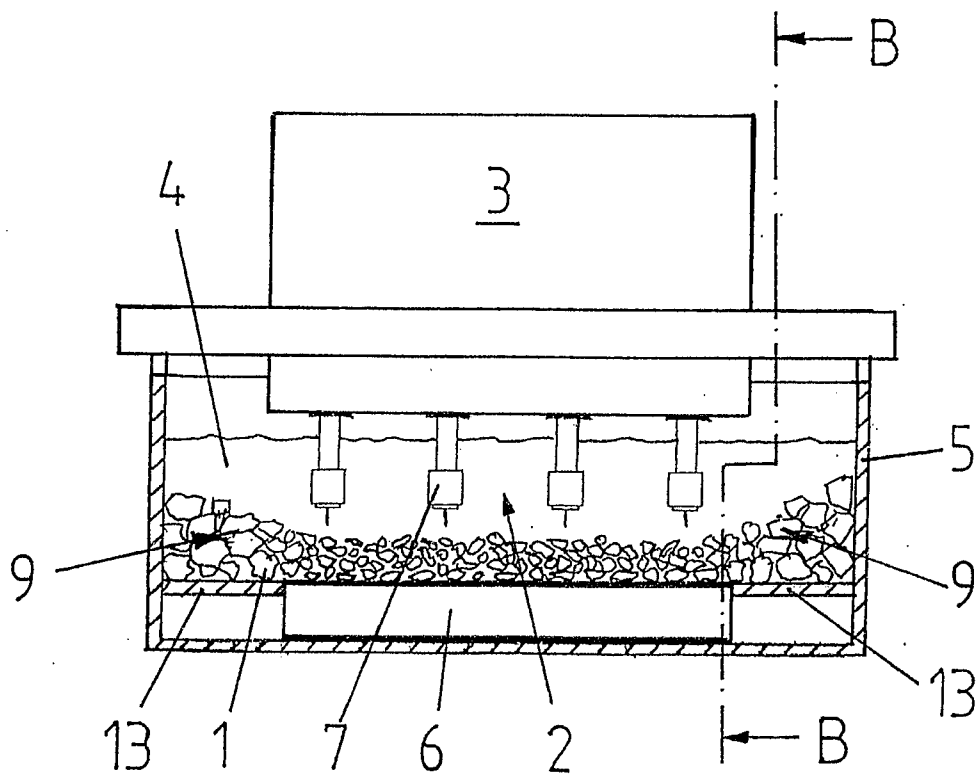
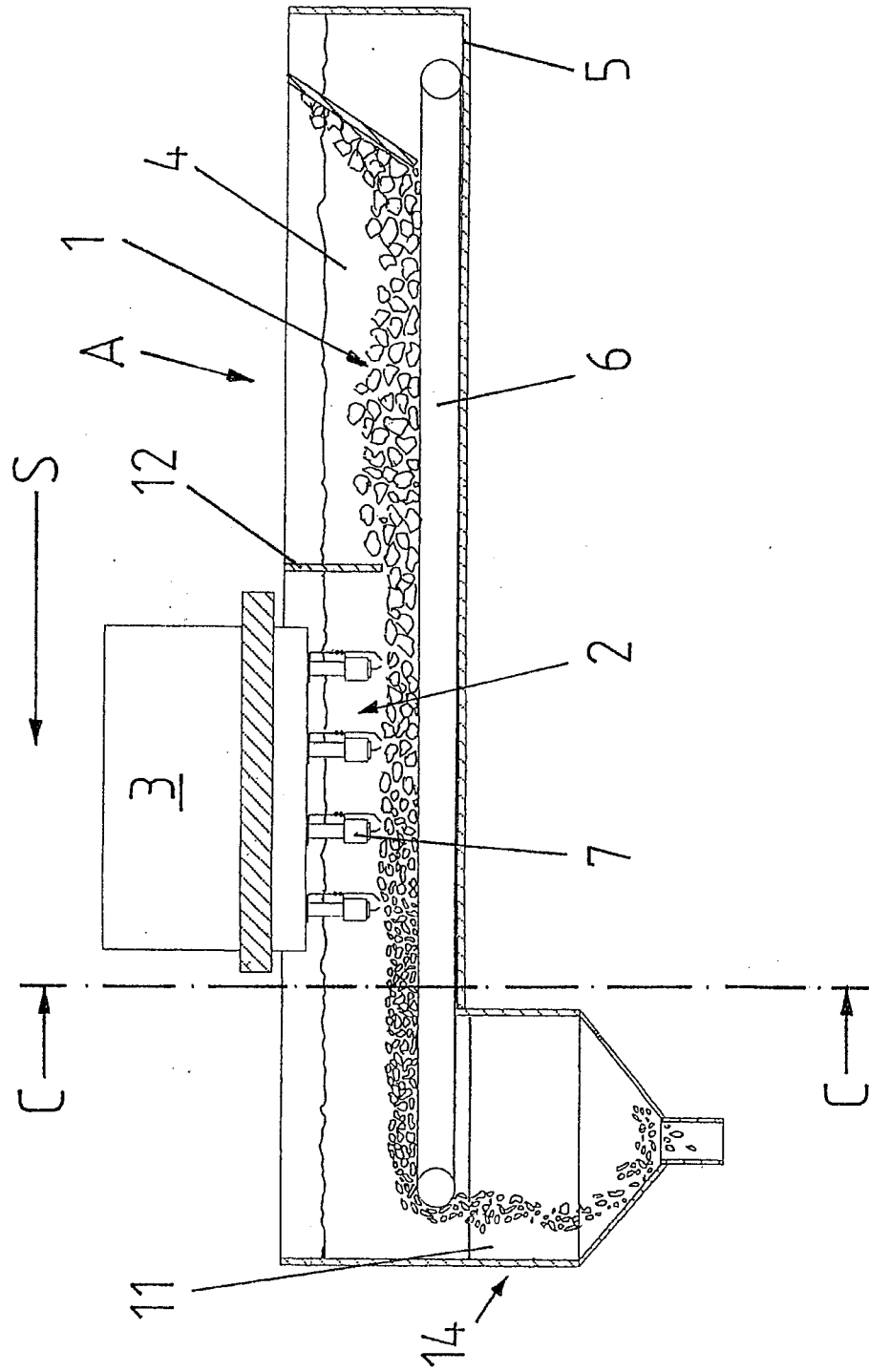


Fig. 4



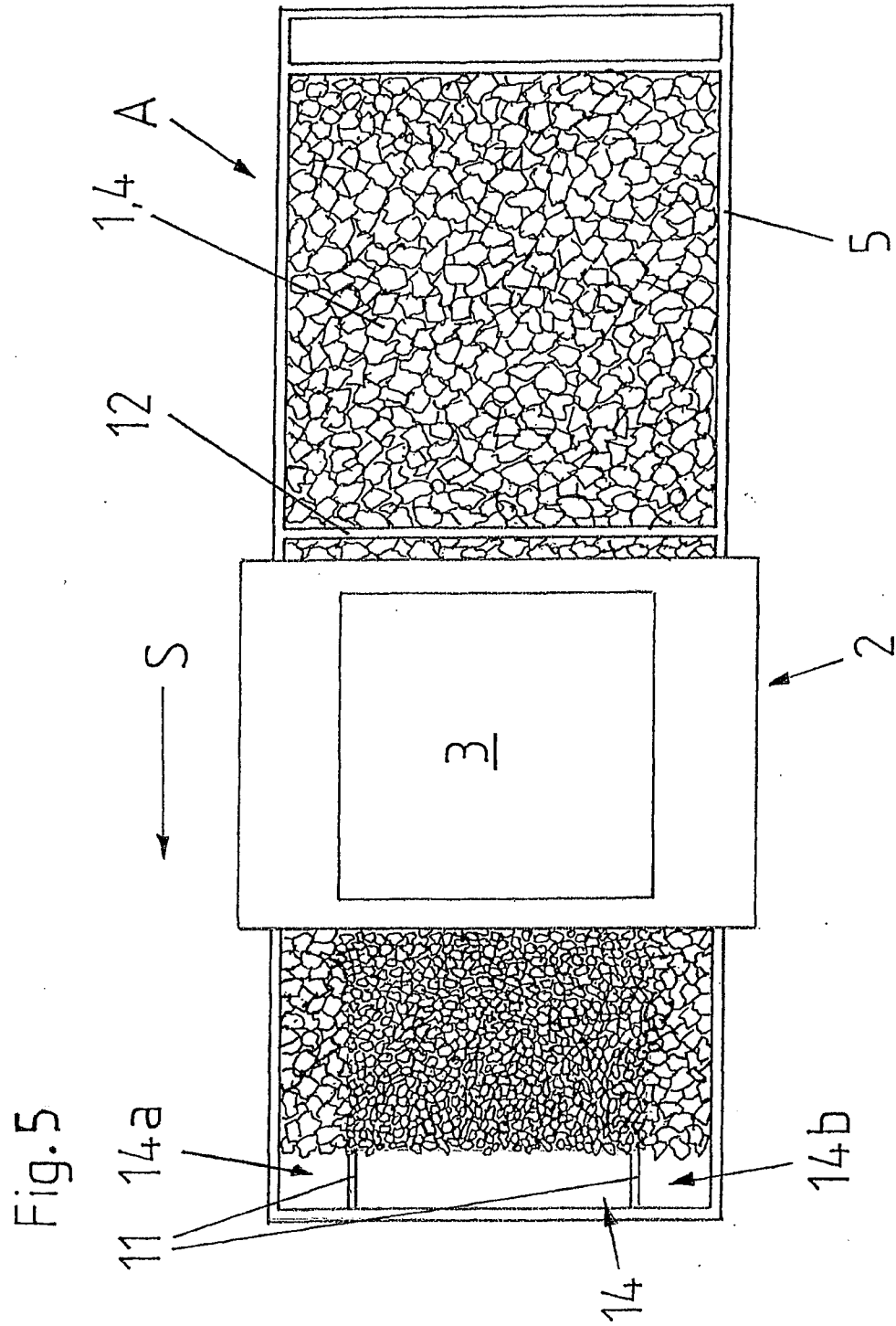


Fig. 6

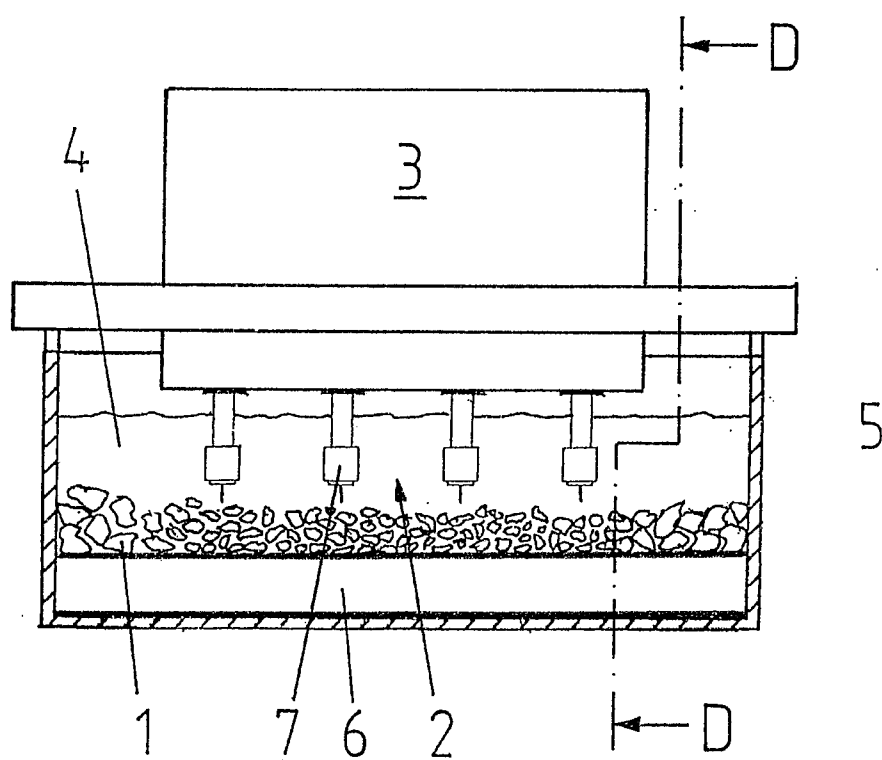


Fig.7

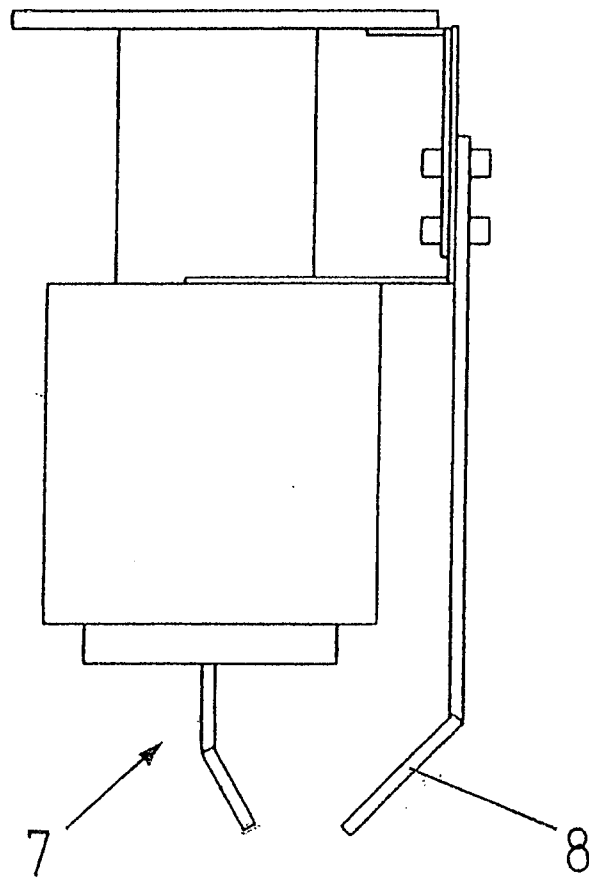


Fig.8

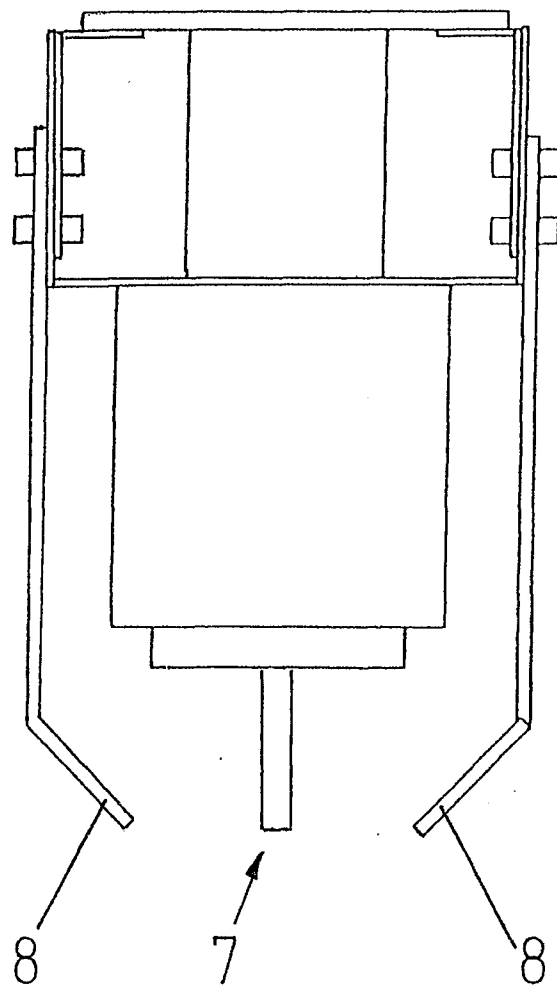


Fig.9

